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PATENT

Case Docket No. ASMEEX.291A

Date: April 9, 2002

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In re application of : Todd, et al.
App. No. : 10/074,563
Filed : February 11, 2002
For : IMPROVED PROCESS FOR
DEPOSITION OF
SEMICONDUCTOR FILMS
Examiner : Unknown
Art Unit : Unknown

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Joseph J. Mallon
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Sir:

Transmitted herewith is a Preliminary Amendment in the above-identified application.

The fee has been calculated as shown below:

CLAIMS AS FILED									
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR		PRESENT EXTRA		RATE		ADDITIONAL FEE
Total Claims	83	—	83	=	0	×	\$18	=	\$0
Independent Claims	7	—	7	=	0	×	\$84	=	\$0
If application has been amended to contain multiple dependent claim(s), then add							\$130	=	\$0
Time Extension Fee									\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT									\$0

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Joseph J. Mallon
Joseph J. Mallon
Registration No. 39,287
Attorney of Record